## Search Notes

## \*10656311\*

Application No.	Applicant(s)	
10/656,311	CHEN ET AL.	
Examiner	Art Unit	•
Paul D Kim	3729	

SEARCHED					
Subclass	Date	Examiner			
603.07 603.11 603.13- 603.16	9/21/2004	PK			
603.18 605					
606					
121-126	9/21/2004	PK			
317					
127 128	9/21/2004	PK			
65					
192.15					
119 122					
5 41					
	Subclass  603.07 603.11 603.13- 603.16 603.18 605  606  121-126  317  127 128  65  192.15  119 122	Subclass Date  603.07 603.11 603.13- 603.16 603.18 605 606  121-126 9/21/2004 317 127 128 9/21/2004 65 192.15 119 122 5			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Reviewed Parent Application 09/617,791 (US PAT. 6,618,223)	9/21/2004	PK		
Text Search EAST/NPL (IEEE)	9/22/2004	PK		
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